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## **Development of a reactor for the in situ monitoring of 2D materials growth on liquid metal catalysts, using synchrotron x-ray scattering, Raman spectroscopy, and optical microscopy**

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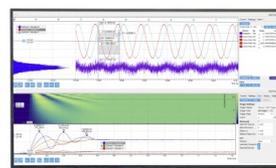
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## ABSTRACT

Liquid metal catalysts (LMCats) (e.g., molten copper) can provide a new mass-production method for two-dimensional materials (2DMs) (e.g., graphene) with significantly higher quality and speed and lower energy and material consumption. To reach such technological excellence, the physicochemical properties of LMCats and the growth mechanisms of 2DMs on LMCats should be investigated. Here, we report the development of a chemical vapor deposition (CVD) reactor which allows the investigation of ongoing chemical reactions on the surface of a molten metal at elevated temperatures and under reactive conditions. The surface of the molten metal is monitored simultaneously using synchrotron x-ray scattering, Raman spectroscopy, and optical microscopy, thereby providing complementary information about the atomic structure and chemical state of the surface. To enable *in situ* characterization on a molten substrate at high temperatures (e.g., ~1370 K for copper), the optical and x-ray windows need to be protected from the evaporating LMCat, reaction products, and intense heat. This has been achieved by creating specific gas-flow patterns inside the reactor. The optimized design of the reactor has been achieved using multiphysics COMSOL simulations, which take into account the heat transfer, fluid dynamics, and transport of LMCat vapor inside the reactor. The setup has been successfully tested and is currently used to investigate the CVD growth of graphene on the surface of molten copper under pressures ranging from medium vacuum up to atmospheric pressure.

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## I. INTRODUCTION

For nanomaterials to have a significant technological impact, efficient production, assembly, and maintenance techniques must

be developed to harvest their unique properties in ubiquitous applications and devices. 2D materials (2DMs), having only one of their dimensions confined at the nanoscale, are expected to be the easiest class of nanomaterials to manipulate and process in a

number of technological applications as compared to 1D or 0D derivatives. Yet, mass production of high-quality 2DMs proves to be a formidable challenge by itself, attested by the number of publications on this topic and the difficulties of scaling up.

The current state-of-the-art synthesis method of 2DMs involves the dissociative adsorption of gas-phase precursors on a solid catalyst. The most well-known example is the chemical vapor deposition (CVD) of graphene on a copper surface at elevated temperatures ( $\sim 1270$  K) using a  $\text{CH}_4$  precursor.<sup>1</sup> The fabrication process is rather slow as it involves multiple steps for substrate preparation, 2DM growth, its separation from the catalyst, and its transfer to a target substrate. Producing a high-quality 2DM layer is also often a challenge as natural imperfections of a solid surface—such as crystalline anisotropies, surface roughness, and structural defects such as grain boundaries or dislocations—can induce defects in the overgrown 2DM. 2DMs can nucleate at multiple points on the surface, each having a different crystalline direction.<sup>1</sup> Upon their coalescence, neighbor domains cannot rotate freely and match their crystalline direction as they are strongly anchored to the solid surface. This leads to a multidomain 2DM structure with typical domain sizes in the order of micrometers. Upon cooling down from high temperatures (needed for 2DM growth) to ambient temperature, the thermal expansion mismatch between the 2DM and the substrate results in the creation of a highly wrinkled 2DM that normally contains flat islands separated by a network of folds.<sup>1,2</sup> The separation and transfer steps add additional bottlenecks in the production process. For the case of graphene, for example, due to extremely high adhesion and friction forces between 2DM and the solid catalyst, it is virtually impossible to directly peel the graphene layer off the solid catalyst surface without destroying it. One common separation method is to first add a backing layer on the 2DM and then etch the catalyst away chemically.<sup>3</sup> This leads to the loss of the metal catalyst, significant waste production, and further damage and contamination of the 2DM. Therefore, the overall process is slow, inefficient, expensive, and environmentally unfriendly.

Of the above mentioned problems, the solid state of the substrate seems to be the common source. By taking a radical approach of synthesizing 2DMs on a liquid metal catalyst (LMCat), one can potentially bypass or reduce these problems at once.<sup>4</sup> The surface of a liquid phase provides the most isotropic, defect-free, and smooth substrate to grow 2DMs on. The dynamic nature of the liquid surface can provide more efficient defect healing during the 2DM growth. Furthermore, the viscous forces on the liquid surface are orders of magnitude less than the frictional forces on a solid. Hence, the nucleated 2DM domains have the possibility to move, rotate, and annihilate their boundary faults upon their coalescence.

Elimination of surface frictional forces and the free mobility of 2DMs on LMCats open an important possibility, namely, direct separation of the 2DM from the liquid substrate.<sup>5</sup> For example, the mechanical strength of graphene is significantly higher than the force needed to shear and directly separate it from the molten copper. To our knowledge, the work of adhesion of graphene on molten copper is not reported, but one would expect it to be reasonably close to the one of graphite on molten copper, which is  $0.3 \text{ J m}^{-2}$  at 1373 K.<sup>6</sup> This translates to  $0.3 \text{ N m}^{-1}$  force per unit length needed to separate the graphene from molten copper. On the other hand,

the mechanical tensile strength of defect-free graphene at 1373 K is predicted to be  $20.7 \text{ N m}^{-1}$ .<sup>7</sup> Introduction of domain boundaries can reduce graphene's strength to  $\sim 35\%$  of the pristine one.<sup>8</sup> So even if one assumes the formation of domain boundaries in graphene on LMCats, graphene's strength is estimated to be at least  $\sim 7.2 \text{ N m}^{-1}$ , which is still  $\sim 24$  times larger than the force needed to separate it directly from the molten copper.

The possibility of direct 2DM separation inspires a potential continuous 2DM production scheme, where a 2DM domain grows from one side by an ongoing CVD reaction on an LMCat, while being separated from the LMCat surface from the other side. By using LMCat technology for continuous 2DM synthesis, the time-consuming steps of substrate preparation, separation, and transfer can be bypassed all at once. Such a process would have the potential to produce a low-defect single-domain 2DM with virtually unlimited length, while the catalyst metal is being reused and not wasted.

Realization of such a technologically demanding process, however, requires detailed knowledge of LMCat catalytic properties and 2DM growth mechanisms on LMCats. Furthermore, controlling such a delicate process requires the development of dedicated instrumentation and methodology capable of *in situ* detection and monitoring of the 2DM growth on an LMCat, under high-temperature and reactive CVD conditions.

While to the best of our knowledge, the idea of continuous 2DM production on an LMCat has never been proposed before, the feasibility of growing 2DMs on LMCats has already been proven. In 2012, Geng *et al.* demonstrated graphene growth on molten copper and found the produced graphene to be a perfect single domain.<sup>9</sup> Soon after, the feasibility of graphene growth on other LMCats including molten Ga, In, and Sn was also reported.<sup>10,11</sup> Recently, LMCats were also successfully utilized to synthesize other 2DMs such as germanene.<sup>12</sup> These studies have demonstrated a myriad of 2DM morphologies and growth modes depending on the reaction parameters, whose complex nucleation, growth, and etching kinetics of 2DMs on an LMCat are poorly understood.<sup>13,14</sup> Several models have been proposed to explain the experimental observations. However, the proposed mechanisms are often based on uncertain assumptions and sometimes contradicting with each other. The origin of this problem is twofold:

- (1) At the moment, there are no experimental facilities or methods available to study the formation of 2DMs on LMCats *in situ* at high temperatures ( $T > 1000$  K). In the experiments done so far, after exposing the LMCats to the 2DM growth conditions in a furnace, the samples were cooled down to room temperature (taking 10s–100s of minutes) and then studied using standard microscopy or spectroscopy techniques. Obtaining an understanding of the active atomic-scale mechanisms on LMCats at the growth conditions from such *ex situ* data obtained from the solidified sample at room temperature can be problematic, if not misleading.
- (2) For traditional catalytic chemical reactions, two fundamental design rules apply: Minimize the energy consumption of the process and maximize the catalyst surface-to-volume ratio to maximize the reaction output. In contrast, in the case of LMCats, a significant amount of heat is needed to melt and

keep the catalyst in liquid form, and a liquid catalyst tends to minimize its surface-to-volume ratio due to surface-tension effects. Hence, for traditional chemical reactions, LMCats had no promising commercial prospects, leading to the lack of motivation for investigating their catalytic properties from a fundamental point-of-view. Accordingly, the current knowledge about the catalytic activity of LMCats is rather scarce and mostly limited to some preliminary studies from before 1985.<sup>15</sup>

As discussed, however, special properties of LMCats can open a new paradigm for the mass production of high-quality 2DMs. To reach such a technological excellence, bridging two major scientific unknowns is of crucial importance: (1) precise knowledge of the mechanism, thermodynamics, and kinetics of nucleation and growth of 2DMs on LMCats, and (2) catalytic properties of LMCats, specifically in relation to the formation of 2DMs on the surface and the interactions between the fluid catalyst and the formed products. Here, we report the development of instrumentation and methodology capable of studying the ongoing chemical reactions on the molten catalyst, with the goal to open two new lines of research, namely, *in situ* investigations on the catalytic activity of LMCats, and more specifically, unraveling the growth mechanisms of 2DMs on LMCat surfaces. This knowledge is key to exploit the unique properties of 2DMs on the industrial scale and in every day devices via the LMCat technology proposed here.

## II. EXPERIMENTAL METHODOLOGY

As the starting point for our investigation, we set our goal on *in situ* study of graphene formation on molten copper. This is one of the most studied 2DM formation processes (*ex situ*) to this day for which there have been several reports showing its general feasibility.<sup>9,16</sup> The choice is further motivated by the fact that the solubility of carbon in molten copper is very low ( $\sim 0.0001$  wt. % carbon at 1370 K),<sup>17</sup> and the vapor pressure of molten copper has one of the lowest values ( $\sim 0.07$  Pa at 1370 K) compared to other LMCats at the high temperatures relevant for graphene growth. Once the graphene/molten copper system has been investigated properly, exploring other LMCats such as Sn, In, and Ga will be a natural follow-up. Our experiments aim to obtain *in situ* information about nucleation and growth of 2DMs as well as the atomic structure and chemical composition of the LMCat surface before the exposure to the precursor gases, during the growth of the 2DM and during the cool-down phase. Due to the limited mean free path of electrons in the high gas-pressure conditions of the CVD process (medium vacuum to atmospheric pressure), the photon-based characterization techniques of Raman spectroscopy and surface x-ray scattering have been chosen as complementary methods to investigate simultaneously the 2DM formation on LMCats.

### A. *In situ* Raman spectroscopy

To study the catalytic properties of LMCats and the formation of 2DMs, the availability of a chemically sensitive technique capable of detecting molecules and chemical bonds is of crucial importance. Among the optical techniques, Raman spectroscopy

has been used extensively for studying nanomaterials in general and graphene (on solid substrates) in particular.<sup>18</sup> This technique is sensitive to detect the traces of the precursor adsorbates, intermediate reaction species, and characteristics of final 2DM products on the LMCat surface, including number of layers, stacking type, defect density, and presence of doping or contamination. Moreover, Raman spectroscopy can provide information about the shape evolution of the 2DM domains and the growth speed of domain boundaries and distribution of chemical compounds on the surface with a spatial resolution in the order of a few hundreds of nanometers.<sup>19</sup> In combination with isotope signaling, *in situ* Raman spectroscopy can provide deeper insight into 2DM nucleation and growth mechanisms.<sup>16</sup>

However, performing *in situ* Raman spectroscopy at high temperatures ( $T > 1000$  K) needs special considerations, otherwise the weak Raman signal could be easily swarmed by the intense thermal radiation of the molten surface. This challenge could be tackled by a number of experimental solutions such as (a) spatial filtering provided by confocal optics to block the background thermal radiation of surface regions surrounding the focal (laser) spot,<sup>20</sup> (b) using laser sources with higher frequencies to shift the Raman-scattered light further away from the thermal radiation spectrum,<sup>21</sup> (c) utilizing the anti-Stokes scattering signal, the intensity of which becomes stronger at higher temperatures due to the higher occupancy of the 2DM vibrational states,<sup>22</sup> and (d) utilizing multiphoton approaches which can increase the efficiency and hence the intensity of the Raman signal significantly.<sup>23</sup> This can provide the opportunity of using lower input power (preventing beam damage on 2DMs), overcoming detector noise, and increasing the imaging speed for known substances. As will be presented later, by implementing some of the above-mentioned measures, Raman experiments have been performed successfully on samples with temperatures up to 2200 K<sup>21,24</sup> and on graphene on SiO<sub>2</sub> substrates with temperatures up to 1450 K.<sup>25</sup>

### B. *In situ* surface x-ray techniques

Obtaining knowledge about the atomic structure of the growing 2DM flakes and of the LMCat surface during the 2DM growth is of critical importance. It is known that differences in surface tension of melt constituents can cause segregation and formation of surface phases that would have a radically different composition compared to the liquid bulk.<sup>26,27</sup> Growing 2DM flakes is expected to influence the underlying LMCat structure by dictating their order onto it. The order is expected to extend outside of the flakes, possibly influencing the lateral growth of the flakes and even giving rise to interactions between neighboring flakes. LMCat-mediated interaction is thus one of the potential mechanisms that can explain the observed self-ordering patterns between separated graphene flakes grown on molten copper.<sup>7</sup> Thermal capillary waves are induced by thermal fluctuation at the molecular scale on the phase boundary of a fluid, whose dynamics are dominated by the surface tension.<sup>26,27</sup> The existence of a 2DM on the surface is expected to change or suppress the capillary-wave spectrum on the melt. The capillary waves, on the other hand, induce a certain effective roughness on the liquid surface, which in turn can influence the catalytic activity of the molten phase. The extent of mutual influence between 2DM, thermal capillary waves, and catalytic activity of the LMCats

and its consequences for the 2DM growth is presently completely unknown.

Our aim is to investigate these effects using surface-sensitive techniques including x-ray reflectivity (XRR) and grazing-incidence x-ray diffraction (GIXD). XRR can probe the liquid electron density profile in out-of-plane direction to the surface, with potential evidence of density oscillations, i.e., out-of-plane layering (which might be correlated with the growing 2DM flakes) as well as the van der Waals gap between the 2DM and the LMCat. GIXD, on the other hand, can provide information on short-range order in the liquid, both parallel and perpendicular to the surface. GIXD can be used to resolve 2DM diffraction rods, whose quantitative measurements can provide the detailed atomic structures in the flakes of the 2DM.<sup>28</sup> The experiments have to be performed under grazing incidence, possibly below the critical angle for total external reflection of x rays in order to enhance the surface to the buck signal ratio. X-ray scattering techniques have already been used to investigate adsorbed organic molecules on the surface of water or mercury at room temperature,<sup>29,30</sup> as well as, on the surface structure of the binary liquid Au-Si alloy system at temperatures up to 650 K.<sup>31</sup> These techniques have also been successfully used to study the structure of graphene grown on solid catalytic substrates.<sup>32,33</sup>

For successful x-ray experiments, the surface of molten copper should be close to flat, e.g., a large radius of curvature, so that the incident x-rays have a well-defined incident angle on the sample. However, molten copper may not wet an untreated flat tungsten substrate and the copper foils may break into small droplets when heated above the melting temperature. A possible way to make the copper film flatter is to roughen the tungsten substrate. This decreases the contact angle of molten copper via Wenzel's equation  $\cos(\theta^*) = r \cos(\theta)$ , where  $\theta^*$  and  $\theta$  are the contact angle on the substrate after and before roughening and  $r$  is the roughness ratio.

### C. Instrumentation requirements

To perform the above-mentioned *in situ* x-ray and Raman experiments, the first step is to develop customized instrumentation, capable of studying the 2DM formation process on the surface of LMCats. Both *in situ* experiments need several common features: gas mixing and analyzing system, controlling units for the reactor including heating, cooling, etc. To guarantee the reproducibility of exact 2DM growth conditions for both Raman and x-ray experiments, we have integrated both techniques in one LMCat reactor. This provides the possibility of simultaneous *in situ* Raman and x-ray experiments and direct comparison of the results. For the design and fabrication of such a novel instrument, several technical challenges need to be addressed:

1. The surface of the liquid metal should be as undisturbed as possible. This is especially important for x-ray measurements where a precise definition of the incident beam on the liquid surface is needed. One potential source of liquid-surface disturbance is the convective currents in the LMCat. Therefore, the heating mechanism inside the reactor has to be designed to minimize these currents at the x-ray beam or Raman laser incident points. The x-ray scattering experiments on a liquid phase need a customized diffractometer capable of keeping

the liquid sample horizontal and fixed in position during the x-ray scans to avoid surface-wave formation on the liquid. Our LMCat reactor is designed to be compatible with liquid-phase diffractometers located at the ESRF-ID10 (in Grenoble, France), DESY-Petra III-P08 (in Hamburg, Germany), Diamond-I07 (in Oxfordshire, UK), and Soleil-SIRIUS/SIXS (in Saint-Aubin, France) synchrotron beamlines.<sup>34-36</sup> For x-ray measurements, the reactor wall is often made of beryllium which has a high transmission in the x-ray range of electromagnetic spectra. As the reactor will be filled with CVD gases with different pressures, this can contribute to unwanted x-ray scattering and absorption. Therefore, the maximum optimal distance between the x-ray window (Be wall) and LMCat would be in the order of  $\sim 10$  cm, assuming use of low (8 keV) and high (24 keV) energy x-rays.

2. For the Raman measurements, a shorter distance between the objective lens and the sample would allow the use of an objective with a higher numerical aperture. This leads to the stronger collected Raman signal, shorter acquisition time, and higher spatial resolution. For room temperature measurements, an objective-sample distance in the order of 1.0 mm is desirable. However, having such a short distance is obviously not an option for studying a molten copper surface at 1370 K. In order to protect the Raman system objective lens against the gases in the reactor and the high-temperature radiation from the LMCat, we have chosen to have an optical window separating the lens and the inner reactor environment. The close distances between extremely hot LMCat and the fragile optical and x-ray windows might potentially lead to heat-shocks and fracture. To protect these windows, an efficient cooling mechanism should be devised to keep the temperature preferably below  $\sim 400$  K during *in situ* measurements.
3. Rapid evaporation of the atoms from the LMCat surface can contribute to surface disturbance, and the evaporated atoms can deposit on reactor windows and disturb the x-ray/Raman measurements. As mentioned, molten copper has one of the lowest vapor pressures compared to other liquid metals at temperatures relevant for graphene CVD growth. Nevertheless, copper evaporates at a rate of about 500 monolayers per second ( $\sim 0.4$  mm/h) in vacuum at 1370 K. The deposited copper layer on the optical and x-ray windows can absorb the laser light/x-rays and eventually disrupt the *in situ* experiments. The optical window (normally quartz or sapphire) could be exchanged more regularly than the x-ray window as the latter is far more expensive and cleaning might be a hazardous task. We have estimated the acceptable deposition rates on both the optical and x-ray windows to be  $\sim 1$  pm/h. This deposition rate is estimated to cause less than 10% absorption of laser light/x-rays passing through optical/x-ray windows during 2 weeks/20 years of continuous reactor service, respectively. To suppress the LMCat evaporation, a noble gas containing the 2DM-formation precursor mixture (e.g.,  $\text{CH}_4$  and  $\text{H}_2$ ) can be used to flow through the reactor. The presence of noble gas in the reactor (1) suppresses the evaporation of the LMCat and (2) slows down the diffusion of evaporated metal toward the windows,<sup>37,38</sup> while (3) by inducing an optimized gas flow pattern in the reactor, evaporated atoms can be swept away by

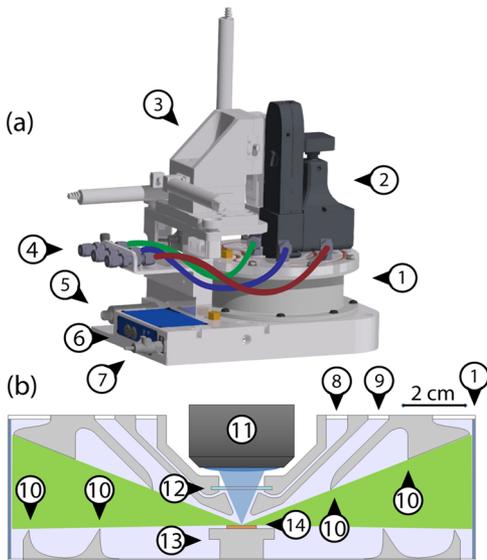
the flow of the carrier gas through the reactor before they can reach the optical windows, and (4) the gas flow can protect and cool down the reactor windows from overheating caused by convection of heated gas and radiation from LMCat. However, the gas flow over the LMCat surface should not be too strong to cause disturbance and surface waves on it.

A noble gas with heavier atomic mass can decrease the LMCat evaporation more efficiently;<sup>37</sup> however, it would also interact with x-rays more strongly, increasing the unwanted x-ray absorption and scattering. We have selected argon as the reactor background gas for its average atomic mass and price. Setting the reactor total inner pressure to  $\sim 1$  bar simplifies the reactor design requirements in comparison with a reactor with lower (high vacuum or lower) or higher inner pressures, i.e., more than 2 bars (all reported pressure values correspond to absolute pressures).

### III. THE REACTOR DESIGN

A schematic of the LMCat reactor is shown in Fig. 1. The reactor has a cylindrical shape with 150 mm inner diameter and 46 mm height. The reactor's cylindrical wall is made of 0.5-mm-thick beryllium (No. 1 in Fig. 1), while the top and bottom parts are made of aluminum with a copper water cooling pipe within.

The custom heater assembly contains a resistive heater element, and it is positioned at the center of the reactor (No. 13). The heater can provide temperatures exceeding  $\sim 1800$  K. The sample holder consists of a tungsten disk, which is fixated by a clamping mechanism on the heater and is in direct contact with a thermocouple.



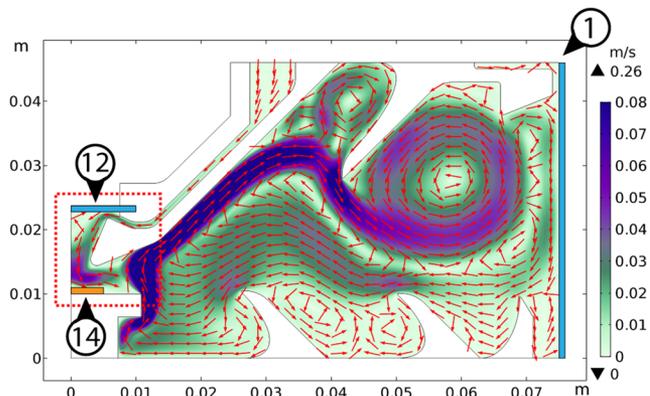
**FIG. 1.** Schematic of the LMCat reactor showing its outer (a) and inner (b) cross section structures. The components are as follows: 1. cylindrical x-ray window, 2. optical probe (here, a Raman probe with integrated video camera), 3. X-Y-Z translation stage, 4. gas lines in/out of reactor, 5. pressure gauge, 6. heater control unit with power input and thermocouple reading connections, 7. water cooling inlet, 8. gas inlet, 9. gas outlet, 10. flow deflectors, 11. objective lens, 12. optical window, 13. heater, and 14. LMCat sample. The blue and green areas in (b) are the optical and x-ray passages between the windows toward the LMCat sample.

Fresh copper samples can be added to the sample holder as ultrapure foils (No. 14). The sample holder can be accessed by unscrewing the top plate of the reactor. The optical window for the Raman probe is placed directly above the LMCat sample, allowing the Raman objective lens to be as close as 12.7 mm to the sample surface (No. 12).

A 30 mW violet solid-state laser (with an excitation wavelength of 405 nm) has been chosen for the Raman experiments in order to reduce the black body radiation effect. The laser is delivered to the Raman probe (No. 2) by means of an optical fiber cable. The probe is equipped with microscopic long-working-distance objectives (No. 11) and is mounted on a motorized XYZ positioning system (manipulator) over the reactor which can adjust the positioning of the Raman objective lens in the optical port within a range of 25.4 mm with  $\pm 2.5$   $\mu\text{m}$  accuracy (No. 3). As already mentioned, the 2DM/LMCat can also be investigated via the same optical port by other optical methods such as optical microscopy, reflectometry, or pyrometry.

Extensive COMSOL Multiphysics simulations have been performed to optimize the reactor's inner design and gas flow pattern. This is to satisfy the two design criteria, i.e., (1) minimize the deposition rate of Cu on the windows to below  $\sim 1$  pm/h and (2) minimize the temperature of windows to below 400 K, while also minimizing the required gas inlet flux for window protection. A specially designed gas-flow pattern inside the reactor is used to redirect the hot and copper-rich gas, rising from the LMCat, and prohibits it to get in contact with the optical/x-ray windows.

For a specific heater temperature and inlet gas flow rates, coupled heat transfer and fluid dynamic COMSOL modules have been used to simulate the gas flow and temperature distribution in the reactor. To capture turbulent convection (due to the high temperature of the heater) and strong interactions of gas with the flow deflectors, the L-VEL turbulent model was used to describe the gas flow. The heat transfer calculations included conduction in the solids,

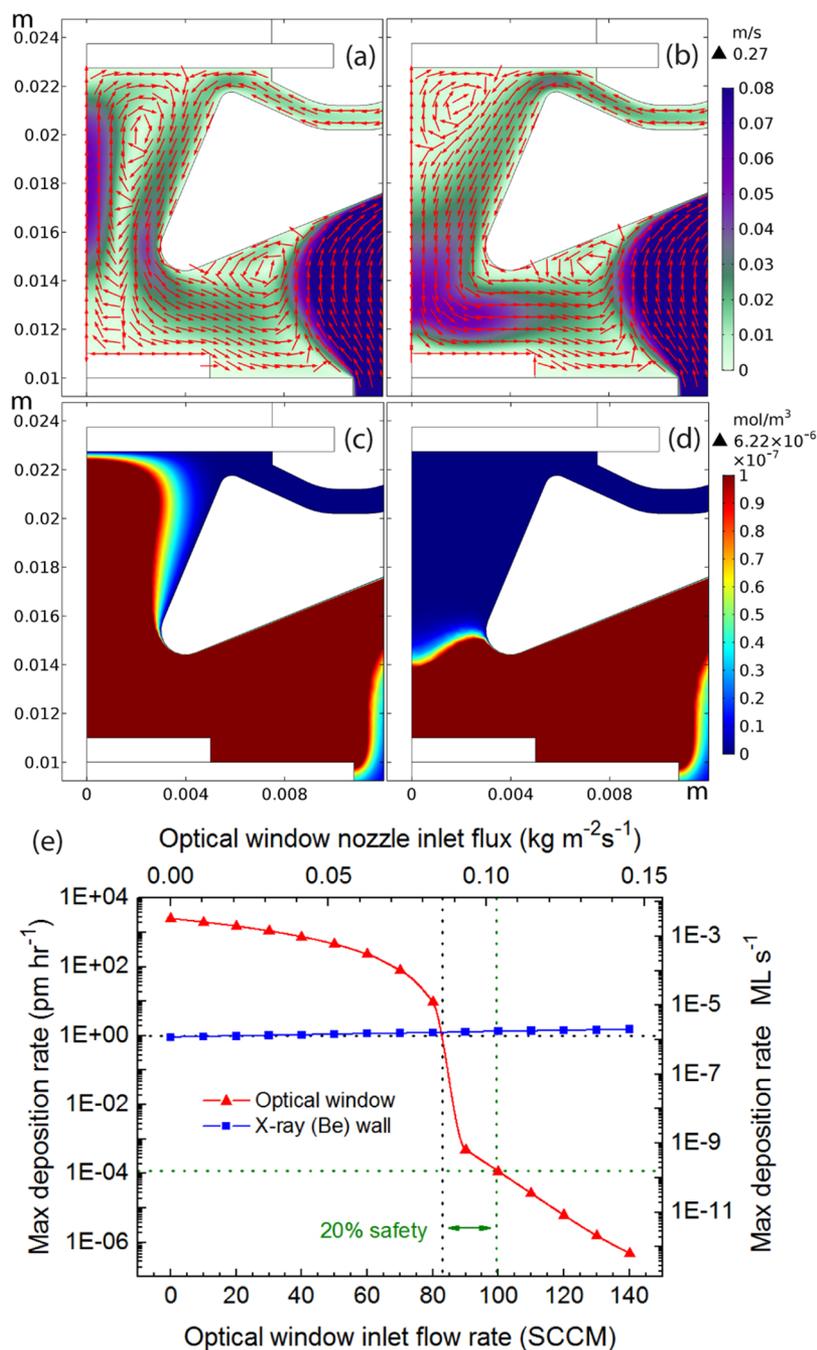


**FIG. 2.** The optimized inner design of the LMCat reactor and simulated gas flow pattern in it. The figure shows half of the reactor's cross section. The red arrows show the gas-flow direction, the color scale shows the gas velocity (m/s), and the dotted box outlines the zoomed-in area in Figs. 3(a)–3(d). The simulation has assumed a flow rate of 100 sccm for the optical window inlet, an outlet pressure of 1 bar, a heater temperature of 1370 K, and a bottom and top plate temperature of 293 K. The marked numbers correspond to entities described in Fig. 1(b).

convection in the gas, and radiation from the heater, while setting the water cooled top and bottom reactor plates to room temperature. After converging to a self-consistent solution, the stationary flow pattern was used to predict the transport of copper vapor rising from the LMCat surface in the reactor. The adsorption coefficient of copper vapor was set to 100% on the reactor walls and windows. From the concentration distribution of copper vapor in the reactor,

finally one can deduce the deposition rate of copper on the reactor's inner surfaces.

The cylindrical symmetry of the reactor ensures a symmetric gas flow pattern, providing the possibility of uniform protection of optical/x-ray windows for the whole 360° azimuthal angles. The gas in/outlets to the reactor in Fig. 1 (Nos. 8 and 9) are hence ring-shaped openings, located on the top or bottom plates of the reactor.



**FIG. 3.** The gas flow pattern and velocity in m/s [(a) and (b)] and copper vapor concentration in mole/m<sup>3</sup> [(c) and (d)] near the optical window (the outlined area in Fig. 2) as a function of window gas inlet. The gas inlet-flow rates are 60 sccm [(a) and (c)] and 90 sccm [(b) and (d)]. (e) Shows the relation between the flow rate of the optical-window inlet and the maximum deposition rates on the optical and x-ray windows for the reactor design shown in Fig. 2. The black dotted line shows the 1.0 pm/h protection criterion, and the green dotted line is our selected inlet flow rate which includes a 20% safety margin for optical window protection.

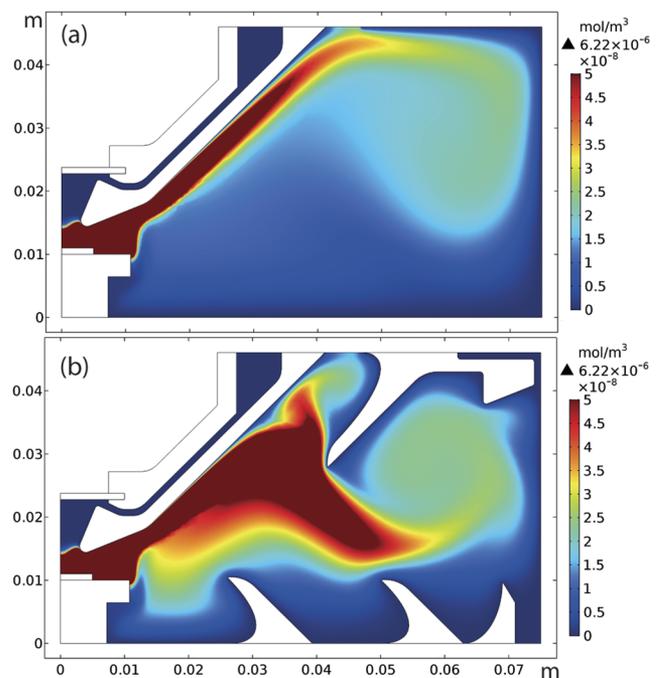
In the final design, special precautions have been taken to symmetrize the real gas flows as much as possible. A flow of gas mixture, containing the graphene growth precursors ( $\text{CH}_4$  and  $\text{H}_2$ ), enters the reactor via the gas inlet (No. 8), directed toward the optical window; see Fig. 2. The gas exits via a ring-shaped nozzle and then funneling downward toward the LMCat sample; see Figs. 3(a) and 3(b). The funneling region provides an optical cone of  $45^\circ$  between the objective lens and the LMCat sample. After passing over the LMCat, the gas exits the reactor via the gas outlet (No. 9).

By having sufficient inlet-flow rate for the optical window, the window is only in contact with fresh gas and hence is protected from the hot and copper-rich gas rising from the LMCat; see Figs. 3(c) and 3(d). Figure 3(e) shows the predicted copper deposition rates on the optical window as a function of inlet-flow rate of the optical window. There is a sharp drop in the copper deposition rate on the optical window from about 80 to 90 sccm, which corresponds to a sharp transition in the gas flow pattern in the funneling region below the optical window [compare Figs. 3(a) and 3(b)]. For having  $\sim 1.0$  pm/h copper deposition rate on the optical window, one would need  $\sim 85$  sccm inlet-flow rate. We chose 100 sccm as a safe operational flow rate of the optical window, which includes a 20% safety factor, which leads to a predicted copper deposition rate of  $1.15 \times 10^{-4}$  pm/h ( $1.51 \times 10^{-10}$  monolayers per second) on the optical window. Higher inlet-flux values are not favorable as they increase the chance of the LMCat surface to be disturbed by the high-speed gas flow and increase the Ar consumption. The maximum temperature on the window is predicted to be 351 K, only  $58^\circ$  warmer than the inlet gas temperature, mainly caused by the radiation from the LMCat; see the [supplementary material](#) for more information about this. Hence, our protection criteria for the optical window are well satisfied.

Without further precautionary measures, the deflected copper-rich gas tends to establish a convective vortex inside the reactor's main space. Due to the reactor's cylindrical symmetry, the vortex is donut-shaped, rising to the reactor upper part at the outer surface of the optical window shield and descending toward the reactor bottom at the side of the x-ray window. Such a vortex can transfer and deposit the evaporated copper atoms to/on the x-ray window; see Fig. 4(a).

To further decrease the copper vapor spread toward the x-ray window, several flow deflectors are placed at the top and bottom plates of the reactor (No. 10 in Fig. 1). Instead of having one large vortex circulating across the entire reactor, the flow deflectors break the convective current into several smaller vortices; see Fig. 2. These vortices increase the effective path length for the evaporated copper from the LMCat to the x-ray window, while the flow deflectors increase the total inner surface area of the reactor. Hence, each vortex acts as a filter for the evaporated copper atoms. The deposited copper on the flow deflectors poses no risks for the reactor performance as the maximum rate of deposition on the flow deflectors is too low (2.16 nm/h) to make a significant change to the geometry of the reactor, even after decades of continuous service; see the [supplementary material](#). Simulation has predicted that the presence of the flow deflectors in Fig. 4(b) reduces the average copper deposition rate on the x-ray window by 37% compared to Fig. 4(a).

In our design, the reactor outlet is located at the top of the reactor just outside of the optical-window shield. In addition, an outlet



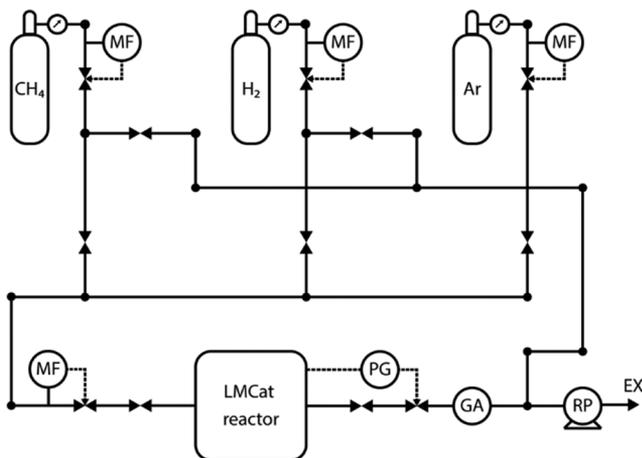
**FIG. 4.** The effect of flow deflectors on the distribution of copper vapor in the reactor. The performance of flow deflectors is shown for the chamber without flow deflectors (a) and with flow deflectors (b). The simulations have been done under the same conditions as those reported in Fig. 2.

shell (top middle flow deflector) is used to bring the gas-extraction point effectively closer to the LMCat sample, where copper density is the highest. This way, one can maximize copper-vapor extraction, hence further reducing Cu deposition on the x-ray window, without blocking the x-ray path.

Simulations show that by using the flow-deflectors, the maximum deposition rate on the x-ray window is 1.33 pm/h ( $1.75 \times 10^{-6}$  monolayers per second) comparable to our protection criterion ( $\sim 1$  pm/h). The x-ray window protection is virtually independent of the inlet flow of the optical window [see Fig. 3(e)]. The flow deflectors are made from aluminum and connected to the water-cooled top and bottom reactor plates. Hence, the hot gas is also effectively cooled down before reaching the x-ray window. In our simulations, the maximum temperature of the x-ray window is 301.0 K, only  $\sim 8^\circ$  warmer than the inlet gas temperature (see [supplementary material](#)).

Since for the x-ray experiments, a grazing angle range of  $-1^\circ$  to  $+22^\circ$  is needed, the flow deflectors are designed such to allow the passage of x-ray in this range. The cylindrical x-ray window enables  $360^\circ$  azimuthal access to the sample surface. However, there are two columns to support the Raman probe on top, which block the passage of x rays by  $9^\circ$  and  $64^\circ$  azimuthal angles. This leaves two open azimuthal angles of  $203^\circ$  and  $84^\circ$  for the x-ray passage.

The custom-built gas handling system of the setup can mix up to 3 gases with controllable mass flow ratios, split the gas mixture into two separate gas lines with controllable flow ratios, and deliver them to the optical and x-ray window inlets in the reactor. A gas



**FIG. 5.** The gas handling system of the LMCat reactor. The abbreviations are MF: mass flow controller, PG: pressure gage controlled variable valve, GA: gas analyzer, RP: rotary pump, and EX: exhaust.

analyzer monitors the exhaust gas composition, extracted from the reactor outlet. A membrane rotary pump extracts the outlet gas from the reactor, while a combination of a pressure sensor and variable valve at the exhaust line sets the total pressure of the reactor via a feedback-loop mechanism; see Fig. 5. The power of the heater is also set using a feedback loop, using the temperature reading of the thermocouple inside the sample holder. Both the sample heating and gas handling systems are controlled by computer-controlled electronics, developed specifically for this setup.

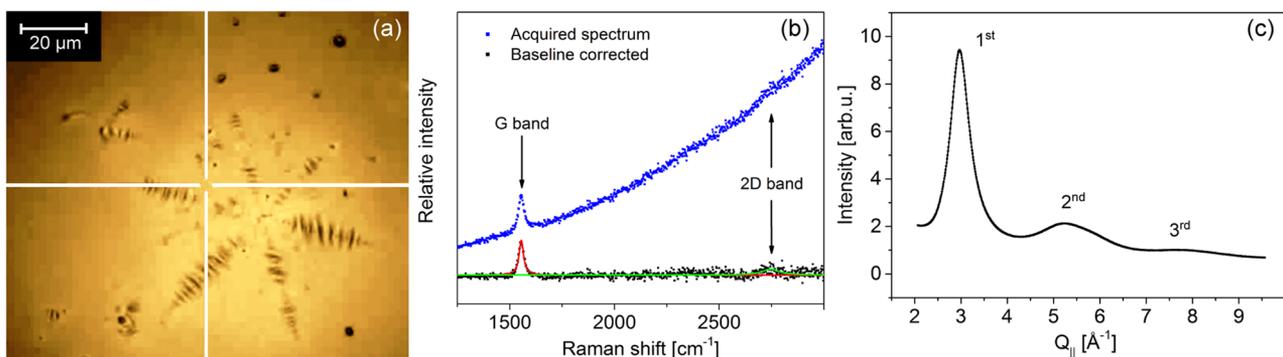
#### IV. THE REACTOR PERFORMANCE

During its first year of commissioning, the setup has been thoroughly tested and several successful *in situ* experiments have been performed. Copper foils of 99.99% purity have been molten on the tungsten substrate. Many graphene-growth experiments have been performed while being studied *in situ* using synchrotron

surface x-ray diffraction, Raman spectroscopy, and optical microscopy, at temperatures around 1370 K. Here, we present some examples of the obtained results to demonstrate the capabilities of the new instrument.

Figure 6(a) shows the *in situ* optical microscope image of a graphene flake during its growth on the molten copper surface. Figure 6(b) shows Raman spectra obtained on the same flake. Despite the intense blackbody radiation background at 1370 K, the G band and 2D band of the graphene are visible in the spectra. The signal-to-noise ratio is significantly less than the one obtained at room temperature; however, this result confirms that *in situ* Raman spectroscopy can be employed to monitor 2DMs formation at high temperatures. Figure 6(c) shows results from *in situ* synchrotron x-ray scattering obtained on molten copper in our reactor. The results have been obtained by in-plane GIXD scans during experiments at 1D10-ESRF beamline. The recorded intensity is related to the liquid interference function, which is the Fourier transform of the liquid atomic pair correlation function, parallel to and below the liquid surface. Detailed analysis of the obtained *in situ* data by the optical, Raman, and x-ray techniques will be discussed in separate publications.

To investigate the copper deposition rate on the windows, we prepared silicon samples cut from highly polished wafers and fabricated strips of  $1\ \mu\text{m} \times 10\ \text{mm}$  of photoresist on them. The Si samples were placed at the optical and x-ray windows where they were exposed to potential copper vapor. We kept the copper molten for 215 min, while flowing 10 sccm  $\text{H}_2$  and 90 sccm Ar (with a purity of 6N grade) from the optical window inlet and keeping the total pressure of the chamber at  $\sim 1$  bar. The hydrogen was added to avoid unwanted oxidation by the trace of oxygen impurity in the Ar gas. After that, the strips on Si-samples were cleaned by a liftoff process in acetone. The surface was then checked with a profilometer to measure the thickness of deposited copper. The intrinsic roughness of the Si surface and the resolution of the profilometer sets the minimum measurable Cu thickness to  $\sim 20$  nm, and within this uncertainty, we could not detect any measurable copper thickness on the Si samples. By inspecting the optical and x-ray window after more than six months of experiments, we do not see any significant copper deposition on optical or x-ray windows. This



**FIG. 6.** Examples of *in situ* characterization of molten copper and graphene using the newly developed LMCat reactor. (a) *In situ* optical microscopy of a graphene flake on molten copper at 1370 K, (b) *in situ* Raman spectroscopy at the indicated point (white cross) in (a), (c) *in situ* grazing incident x-ray diffraction experiment (in-plane scan) on molten copper, related to in-plane the atomic correlation length at the surface of the molten phase.

overall evidence points toward efficient protection of the windows from the heat and the metal vapor.

## V. CONCLUSIONS

In this article, we described the development of our “LMCat reactor” which is capable of *in situ* studies of 2D material formation on the surface of liquid metal catalysts, using simultaneously synchrotron x-ray scattering and photon-based techniques such as optical microscopy and Raman spectroscopy. By inducing a specific gas-flow pattern inside the reactor, the optical and x-ray windows are protected from the heat and the deposition of the vapor coming from the molten substrate (the catalyst). This setup has proven its capability for *in situ* investigation of graphene formation on molten copper at 1370 K. The setup can be used for *in situ* studies on a myriad of other chemical reactions, occurring on molten or solid surfaces at high temperatures and under medium vacuum to atmospheric pressures.

## SUPPLEMENTARY MATERIAL

In the [supplementary material](#), we show additional information on the copper deposition rate on the reactor inner surfaces and the temperature distribution in the reactor. The simulations have been done under the same conditions as those reported in [Fig. 2](#).

## AUTHOR'S CONTRIBUTIONS

Virtually every member of the LMCat consortium has contributed to every aspect of the project. But the main contributors for this paper can be listed as following: Inspiration of the LMCat project and establishment of its consortium was mainly realized via M.S. in U. Leiden. All the PIs of the consortium supported the process, especially I.M.N.G. in U. Leiden who holds the coordinator responsibility of the project. The protection mechanism of windows for *in situ* measurements was mainly conceptualized and optimized via M.S. using COMSOL simulations. The LMCat reactor and its supporting systems were designed and manufactured via LPM (J.M.V., A.S., and G.J.C.B.). The Raman spectrometer was arranged via U. Patras (A.M., C.G.). The experiments have been carried out and analyzed via a collaboration between CEA (M.J., G.R.), ESRF (F.L., O.K.), U. Patras, and U. Leiden.

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## REFERENCES

- <sup>1</sup>C. Mattevi, H. Kim, and M. Chhowalla, *J. Mater. Chem.* **21**, 3324 (2011).
- <sup>2</sup>Z. Li, I. A. Kinloch, R. J. Young, K. S. Novoselov, G. Anagnostopoulos, J. Parthenios, C. Galiotis, K. Papagelis, C.-Y. Lu, and L. Britne, *ACS Nano* **9**, 3917–3925 (2015).
- <sup>3</sup>K. S. Kim, Y. Zhao, H. Jang, S. Y. Lee, J. M. Kim, K. S. Kim, J.-H. Ahn, P. Kim, J.-Y. Choi, and B. H. Hong, *Nature* **457**, 706 (2009).
- <sup>4</sup>P. Kula, W. Szymański, Ł. Kołodziejczyk, R. Atraszkiewicz, K. Dybowski, J. Grabarczyk, R. Pietrasik, P. Niedzielski, Ł. Kaczmarek, and M. Cłapa, *Arch. Metall. Mater.* **60**, 2535 (2015).
- <sup>5</sup>P. Kula, R. Pietrasik, R. Atraszkiewicz, K. Dybowski, W. Modrzyk, P. Z. Zawistowski, and B. M. Klinowski, Patent application WO 2014/035264 A1, 2014.
- <sup>6</sup>R. A. Munson, *Carbon* **5**, 471–474 (1967).
- <sup>7</sup>H. Zhao and N. R. Aluru, *J. Appl. Phys.* **108**, 064321 (2010).
- <sup>8</sup>J. Han, S. Ryu, D. Sohn, and S. Im, *Carbon* **68**, 250–257 (2014).
- <sup>9</sup>D. Geng, B. Wu, Y. Guo, L. Huang, Y. Xue, J. Chen, G. Yu, L. Jiang, W. Hu, and Y. Liu, *Proc. Natl. Acad. Sci. U. S. A.* **109**, 7992 (2012).
- <sup>10</sup>J. Wang, M. Zeng, L. Tan, B. Dai, Y. Deng, M. Rummeli, H. Xu, Z. Li, S. Wang, L. Peng, J. Eckert, and L. Fu, *Sci. Rep.* **3**, 2670 (2013).
- <sup>11</sup>G. Ding, Y. Zhu, S. Wang, Q. Gong, L. Sun, T. Wu, X. Xie, and M. Jiang, *Carbon* **53**, 321 (2013).
- <sup>12</sup>P. Bampoulis, L. Zhang, A. Safaei, R. van Gastel, B. Poelsema, and H. J. W. Zandvliet, *J. Phys.: Condens. Matter* **26**, 442001 (2014).
- <sup>13</sup>D. Geng, B. Wu, Y. Guo, B. Luo, Y. Xue, J. Chen, G. Yu, and Y. Liu, *J. Am. Chem. Soc.* **135**, 6431 (2013).
- <sup>14</sup>D. Geng, L. Meng, B. Chen, E. Gao, W. Yan, H. Yan, B. Luo, J. Xu, H. Wang, Z. Mao, Z. Xu, L. He, Z. Zhang, L. Peng, and G. Yu, *Adv. Mater.* **26**, 6423 (2014).
- <sup>15</sup>Y. Ogino, *Catalysis and Surface Properties of Liquid Metals and Alloys*, Chemical Industries Vol. 29 (Taylor & Francis, 1987).
- <sup>16</sup>M. Zeng, L. Tan, and J. Wang, *Chem. Mater.* **26**, 3637 (2014).
- <sup>17</sup>J. R. Anderson, “Solubility of carbon in molten copper manganese and copper nickel alloy,” M.Sc. thesis, MIT, 1947.
- <sup>18</sup>A. C. Ferrari and D. M. Basko, *Nat. Nanotechnol.* **8**, 235 (2013).
- <sup>19</sup>O. Frank, L. Kavan, and M. Kalb, *Nanoscale* **6**, 6363 (2014).
- <sup>20</sup>I. Daniel, Ph. Gillet, B. T. Poe, and P. F. McMillan, *Phys. Chem. Miner.* **22**, 74 (1995).
- <sup>21</sup>H. Fujimori, M. Yashima, M. Kakihana, and M. Yoshimura, *J. Am. Ceram. Soc.* **84**, 663 (2001).
- <sup>22</sup>H. Fujimori, M. Kakihana, K. Ioku, S. Goto, and M. Yoshimura, *Appl. Phys. Lett.* **79**, 937 (2001).
- <sup>23</sup>E. H. van Veen and D. Roekaerts, *Combust. Sci. Technol.* **175**, 1893 (2003).
- <sup>24</sup>A. G. Kalampounias, S. N. Yannopoulos, and G. N. Papatheodorou, *J. Chem. Phys.* **124**, 014504 (2006).
- <sup>25</sup>S. Berciaud, M. Y. Han, L. E. Brus, P. Kim, and T. F. Heinz, *Phys. Rev. Lett.* **104**, 227401 (2010).
- <sup>26</sup>P. S. Pershan, *Eur. Phys. J.: Spec. Top.* **196**, 109 (2011).
- <sup>27</sup>O. G. Shpyrko, “Experimental x-ray studies of liquid surfaces,” Ph.D. thesis, Harvard University, 2003.
- <sup>28</sup>F. Jean, T. Zhou, N. Blanc, R. Felici, J. Coraux, and G. Renaud, *Phys. Rev. B* **91**, 245424 (2015).
- <sup>29</sup>O. V. Konovalov and A. A. Vorobiev, *J. Appl. Crystallogr.* **46**, 270 (2013).
- <sup>30</sup>H. Kraack, L. Tamam, E. Sloutskin, M. Deutsch, and B. M. Ocko, *Langmuir* **23**, 7571 (2007).
- <sup>31</sup>O. G. Shpyrko, R. Streitel, V. S. K. Balagurusamy, A. Y. Grigoriev, M. Deutsch, B. M. Ocko, M. Meron, B. Lin, and P. S. Pershan, *Science* **313**, 77 (2006).
- <sup>32</sup>N. Blanc, F. Jean, A. V. Krasheninnikov, G. Renaud, and J. Coraux, *Phys. Rev. Lett.* **111**, 085501 (2013).
- <sup>33</sup>T. Schumann, “Direct growth and characterization of graphene layers on insulating substrates,” Ph.D. thesis, Humboldt-Universität zu Berlin, 2014.
- <sup>34</sup>C. Nicklin, T. Arnold, J. Rawle, and A. Warne, *J. Synchrotron Radiat.* **23**, 1245 (2016).
- <sup>35</sup>O. H. Seeck, C. Deiter, K. Pflaum, F. Bertam, A. Beerlink, H. Franz, J. Horbach, H. Schulte-Schrepping, B. M. Murphy, M. Greve, and O. Magnussen, *J. Synchrotron Radiat.* **19**, 30 (2012).
- <sup>36</sup>G. Ciatto, M. H. Chu, P. Fontaine, N. Aubert, H. Renevier, and J. L. Deschanvres, *Thin Solid Films* **617**, 48 (2016).
- <sup>37</sup>O. A. Kashirskaya, V. A. Lotkhov, and V. V. Dilman, *Theor. Found. Chem. Eng.* **44**, 665 (2010).
- <sup>38</sup>D. Manara, M. Sheindlin, W. Heinz, and C. Ronchi, *Rev. Sci. Instrum.* **79**, 113901 (2008).